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Applicant(s): SUGIYAMA, Akinari et al	Confirmation No. 7552
Filing Date: September 18, 2006	Group Art Unit: 1614

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Sub class	Filing Date (If appropriate)
	AA	4,912,269	Drivon et al	3/27/90	570	142	
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(a)	U.S. Pat. No. 4912269	_
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	Please note that publications were cited in the International Search Report mailed on during the international phase of the instant PCT application.
•	Please note that publications (a) to (c) are documents cited in the specification of the above-identified application.
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